



# DATA SHEET

# LP Series - Uncompensated

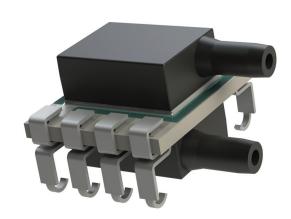
**LP Series - Uncompensated** is a surface mountable pressure sensor package with an uncompensated output suitable for **ultra-low pressure sensing applications**.

COMPANY: Merit Sensor is a leader in piezoresistive pressure sensing and partners with clients to create high performing solutions for a variety of applications and industries.

SENTIUM: Merit Sensor products incorporate a proprietary Sentium® technology developed to provide a best-in-class operating temperature range (-40°C to 85°C) and superior stability.

TECHNOLOGY: Merit Sensor utilizes a piezoresistive Wheatstone bridge in a design that anodically bonds glass to a chemically etched silicon diaphragm. All products are RoHS compliant.

CAPABILITIES: Merit Sensor designs, engineers, fabricates, dices, assembles, tests, sells and services die and packaged products from a state-of-the-art facility near Salt Lake City, Utah





#### **FEATURES**

 $\textbf{Low Pressure} \quad \textbf{0.15 to 1 psi (10.3 to 68.9 mbar; 1.03 to 6.89 KPa;}$ 

**Range** 4.2 to 27.7 in $H_2O$ )

Medium 5 psi to 30 psi (0.34 to 2.1 bar; 34.5 to 207 KPa)

Pressure Range

Type Differential (and Absolute at 15psi and 30psi)

Media Clean, Dry Air and Non-corrosive Gases

Packaging Tape and Reel

Customization Sensitivity, Resistance, Bridge, Constraint, etc.

#### **BENEFITS**

Performance Enjoy best-in-class performance due to Merit's

proprietary Sentium technology

Cost Save money over time with high-performing die

Security Feel confident doing business with an experienced

company backed by a solid parent company

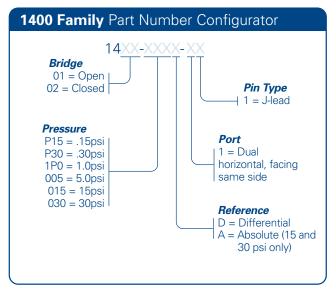
(NASDAQ: MMSI)

Speed Get to market quickly with creative and

flexible solutions

Service Experience prompt, personal and

professional support



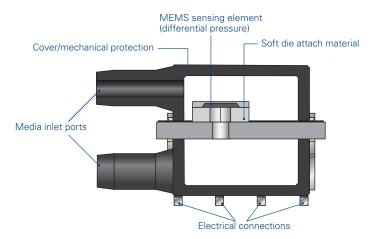


## **SPECIFICATIONS**

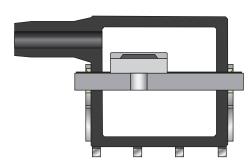
Parameter	Minimum	Typical	Maximum	Units	Notes
Electrical	<u>'</u>		<u>'</u>	•	
Excitation (In)		5	15	V	Maximum: 3mA
Impedance	4000	5000	6000	Ω	
Operating Temperature	-40		85	°C	
Storage Temperature	-55		100	°C	
Performance (0.15psi to 1.00psi					
Offset	-10	0	10	mV/V	Zero Pressure; gage only; @25°C
Non-linearity	-0.25	0	0.25	% FSO	Best Fit Straight Line; @25°C
Pressure Hysteresis	-0.1	0	0.1	% FSO	@25°C
Temp Coeff – Zero	-20	0	20	μV/V/°C	-25°C to 75°C
Temp Coeff – Resistance	2000	2500	3000	PPM/°C	-25°C to 75°C
Temp Coeff – Sensitivity (0.15psi)	-2500	-3000	-3500	PPM/°C	-25°C to 75°C
Temp Coeff – Sensitivity (0.2psi – 1psi)	-2000	-2500	-3000	PPM/°C	-25°C to 75°C
Long-Term Stability	-0.25	0	0.25	% FSO	@125°C
Proof Pressure	5X				Full scale pressure
Burst Pressure	10psi				
Performance (5psi to 30psi)					
Offset	-10	0	10	mV/V	Zero pressure; gage only; @25°C
Non-linearity	-0.25	0	0.25	% FSO	Best Fit Straight Line; @25°C
Pressure Hysteresis	-0.1	0	0.1	% FSO	@25°C
Temp Coeff – Zero	-20	0	20	μV/V/°C	-40°C to 85°C
Temp Coeff – Resistance	2500	3100	3500	PPM/°C	-40°C to 85°C
Temp Coeff – Sensitivity	-1500	-2000	-2500	PPM/°C	-40°C to 85°C
Long-Term Stability	-0.1	0	0.1	% FSO	
Burst Pressure	10X				Full scale pressure
Full Scale Output (@ 5 volts)					
0.15psi (4 inH <sub>2</sub> O; 1.03 KPa)	30	37.5	60	mV	
0.30psi (8.3 inH <sub>2</sub> O; 2.1 KPa)	36	45	54	mV	
1.00psi (27 inH <sub>2</sub> O; 6.9 KPa)	40	50	60	mV	
5 psi (0.34 bar; 34.5 KPa)	107	133	160	mV	
15 psi (1 bar; 103 KPa)	120	150	180	mV	
30 psi (2.1 bar; 207 KPa)	128	160	192	mV	
Media Compatibility					
For Use with non-corrosive dry Solder temperature: max 250 °		max			

# **LP Series – Uncompensated**

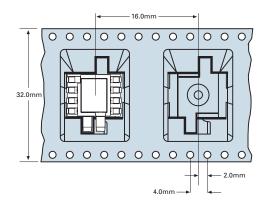
#### **CROSS SECTION FOR DIFFERENTIAL**



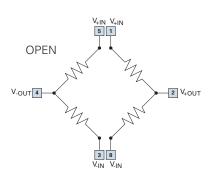
#### **CROSS SECTION FOR ABSOLUTE**



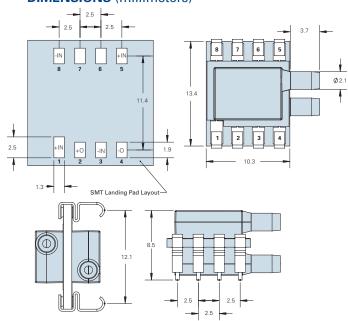
### **PACKAGING**



### **SENSOR BRIDGE Pin-out**



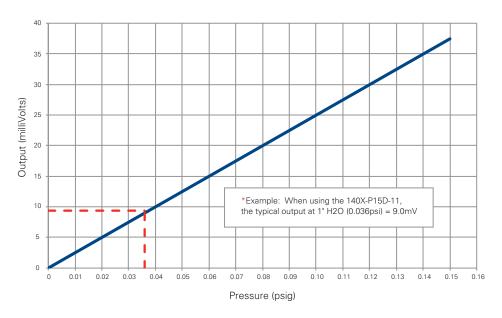
#### **DIMENSIONS** (millimeters)



Device Pinout	Open	Close
P1	+IN	+IN
P2	+0	+0
P3	-IN	-IN
P4	-O	-O
P5	+IN	N/C
P6	N/C	N/C
P7	N/C	N/C
P8	-IN	N/C

#### **Example Transfer Function (Sensor pn 140X-P15D-11):**

 $V_{out} = (250~*~P) + Offset~\pm~Error$  This graph assumes offset = 0mV, error = 0mV, Vs = 5.0V, and TEMP = 25°C





Merit Sensor owns and operates a MEMS wafer fab, which enables the production of customized piezoresistive pressure sensors for medical, industrial, and automotive applications. We help you get to market quickly with creative and flexible solutions and provide prompt, personal, and professional customer support.

